

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) <b>BUR920040087US1</b>		Application Number <b>10/709,793</b>	
				Applicant(s) <b>Andra, et al.</b>			
				Filing Date <b>May 28, 2004</b>		Group Art Unit <b>2171</b>	
<b>U.S. PATENT DOCUMENTS</b>							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES      NO
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
MD		Meyuhas, et al., "THE OPERATIONAL LOGIC BEHIND MANAGING A FULLY AUTOMATED 300 mm FEB", Semiconductor Manufacturing, October 2003, pages 152-159					
MD		Girin, et al., "PROCESS CONTROL THROUGH LITHOGRAPHY AUTOMATION", Semiconductor Manufacturing, July 2003, pages 85-90					
EXAMINER <b>/Mahesh Dwivedi/</b>				DATE CONSIDERED <b>08/14/2006</b>			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							